

DO NOT ENTER: /G.G./ (02/26/2009)

ATTORNEY DOCKET NO:72096

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : TAKAMATSU  
Serial No : 10/565,879  
Confirm. No : 7943  
Filed : January 23, 2006  
For : WAFER POLISHING METHOD  
Art Unit : 1792  
Examiner : George A. Goudreau  
Dated : February 18, 2009

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

In response to the Final rejection dated November 26, 2008, please amend the above identified application as follows:

DO NOT ENTER: /G.G./ (02/26/2009)